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Analysis of $L2_1$ -ordering in full-Heusler Co_2FeSi alloy thin films formed by rapid thermal annealing

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The authors developed a new analysis approach for evaluation of atomic ordering in full-Heusler alloys, which is extension of the commonly used Webster model. Our model can give accurate physical formalism for the degree of atomic ordering in the $L2_1$ structure, including correction with respect to the fully disordered $A2$ structure, i.e., the model can directly evaluate the degree of $L2_1$ ordering under a lower ordering structure than the complete $B2$ -ordering structure. The proposed model was applied to full-Heusler Co_2FeSi alloy thin films formed by rapid thermal annealing. The film formed at $T_A=800$ °C showed a high degree of $L2_1$ ordering of 83% under a high degree of $B2$ ordering of 97%. © 2009 American Institute of Physics. [DOI: 10.1063/1.3075989]

Recently, full-Heusler alloys, such as Co_2FeSi (Ref. 1) and Co_2MnSi ,^{2,3} attract considerable attention since they have a unique half-metallic band structure⁴ with high Currie temperature. In particular, Si-containing full-Heusler alloys are a promising material for spin injector/detector of Si-based spin devices such as spin metal-oxide-semiconductor field-effect transistors,⁵⁻⁷ since they can be formed by silicidation reaction activated by rapid thermal annealing (RTA) that is commonly used formation process for metal source/drain technology in advanced CMOS devices. Recently, we reported that full-Heusler Co_2FeSi alloy thin films were successfully formed by RTA using silicon-on-insulator (SOI) substrates.⁸

A fully ordered atomic arrangement in full-Heusler alloys is the $L2_1$ structure, however, the partially disordered $B2$ and fully disordered $A2$ structures also exist. Half-metallicity in full-Heusler alloys is sensitive to their atomic arrangement and degrades with deterioration of atomic ordering.⁹ Therefore, characterization of atomic ordering in the $L2_1$ structure is an important concern for half-metallic full-Heusler alloys.¹⁰ Nevertheless, the standard approach to evaluate the degree of atomic ordering in full-Heusler alloys still leaves some issues. In this paper, we developed a novel analysis approach to evaluate atomic ordering in full-Heusler alloys, extending the commonly used Webster scheme. The proposed model was applied to full-Heusler Co_2FeSi alloy thin films formed by RTA.

The $L2_1$ structure of full-Heusler X_2YZ alloys (such as Co_2FeSi) is composed of eight stacked body-centered cubic (bcc) lattices shown in Fig. 1(a). The outside sublattice that consists of the eight cubic lattices is occupied by X atoms, and the inside cubic sublattice that consists of the body-centered sites of each bcc lattice is regularly occupied by Y

and Z atoms, as shown in Fig. 1(b). In full-Heusler alloys, two kinds of disordering exist. When the YZ sublattice is randomly occupied by Y and Z atoms, i.e., disordering in the YZ sublattice occurs, the ordering structure is reduced to the $B2$ type. (Hereafter, this disorder process is denoted by Y - Z disordering.) Furthermore, when disordering between the X and YZ sublattices occurs, the ordering structure is lowered to the $A2$ type. (Hereafter, this disorder process is referred to as X - YZ disordering.) In general, these ordered/disordered structures can be identified by x-ray diffraction (XRD) analysis using the following features on relations between atomic orderings and superlattice diffraction lines: Y - Z disordering extinguishes odd superlattice diffraction lines [that are defined by the index relation of h , k , and l =odd numbers, e.g., (111)]. Furthermore, even superlattice diffraction lines [($h+k+l$)/2=2n+1, e.g., (200)] vanish under X - YZ disordering. On the other hand, fundamental diffraction lines [($h+k+l$)/2=2n, e.g., (220)] are independent of the ordering structures.

The traditional analysis approach^{11,12} proposed by Webster has been extensively used to evaluate the degree of atomic ordering in full-Heusler alloys. In the Webster framework, ordering features in full-Heusler alloys are divided into two factors, i.e., the degree of $B2$ ordering, and the degree of $L2_1$ ordering. The degree of $B2$ ordering, S_{B2}^W , represents that of X - YZ disordering (the definition will be discussed later). Although the degree of $L2_1$ ordering, $S_{L2_1}^W$, can

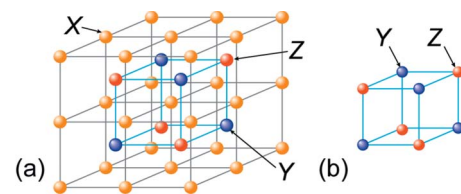


FIG. 1. (Color online) Schematic view of (a) the $L2_1$ structure and (b) the inside cubic sublattice.

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TABLE I. Definition of the number of atoms at each site in full-Heulser Co_2FeSi alloy (in unit of a $\text{Co}_2\text{Fe}_1\text{Si}_1$ molecule).

	X sites	Y sites	Z sites
Number of Co atoms	$2x$	$1-x$	$1-x$
Number of Fe atoms	$1-x$	y	$x-y$
Number of Si atoms	$1-x$	$x-y$	y

be defined by the same manner as that of $B2$ ordering (also discussed later), the disordering parameter α^W that is defined by a fraction of Y atoms on the Z sites is generally used to evaluate $L2_1$ ordering. Both $S_{L2_1}^W$ and α^W represent an index of the degree of Y - Z disordering, however, the definition and physical meaning are different. S_{B2}^W , $S_{L2_1}^W$, and α^W can be easily determined from XRD intensity ratios between superlattice and fundamental lines.^{11,12} (The corrected formula to deduce α^W was presented in Ref. 12.) The Webster model can give accurate formalism for the degree of $B2$ ordering.¹¹ On the other hand, α^W is given under the hypothesis of the complete $B2$ structure of $S_{B2}^W=100\%$. Namely, α^W in the Webster model has no influence of X - YZ disordering. In other words, when S_{B2}^W is less than 100%, the physical meaning of α^W is ambiguous. It should be noted that although α^W represents the fraction of Y atoms on the Z sites, the number of Y atoms on the Z sites also depends on the degree of $B2$ ordering.

Extending the Webster model, we developed physical formalism for the degree of $L2_1$ ordering including correction from the degree of $B2$ ordering. Table I shows a definition of the number of atoms on each site (in unit of a $\text{Co}_2\text{Fe}_1\text{Si}_1$ molecule). In the table, $2x(0.5 \leq x \leq 1)$ and $y(x/2 \leq y \leq x)$ are the number $n_{\text{Co on } X}$ of Co atoms on the X sites, and the number $n_{\text{Fe on } Y}$ of Fe atoms on the Y sites, respectively. The number of Si atoms on the Z sites is also y , where we assumed that X - Y and X - Z disorderings occur equiprobably, which is the same as the assumption of the Webster model.^{11,12} The other values can be easily deduced under the assumption of the stoichiometric composition. The proposed model can express two X - YZ and Y - Z disorderings simultaneously. The degree of $B2$ ordering, S_{B2} , is defined as follows:

$$S_{B2} = \frac{n_{\text{Co on } X} - n_{\text{Co on } X}^{\text{random}}}{n_{\text{Co on } X}^{\text{full-order}} - n_{\text{Co on } X}^{\text{random}}} = 2x - 1, \quad (1)$$

where $n_{\text{Co on } X}^{\text{random}} (=1)$ is the number of Co atoms on the X sites for the most random distribution of Co atoms in the $A2$ structure, and $n_{\text{Co on } X}^{\text{full-order}} (=2)$ is the number of Co atoms on the X sites in the fully ordered X sublattice of the perfect $B2$ structure. In practice, S_{B2} can be obtained from XRD measurements using the following relation between even superlattice and fundamental lines:

$$\frac{I_{200}}{I_{220}} = (2x - 1)^2 \frac{I_{200}^{\text{full-order}}}{I_{220}^{\text{full-order}}} = S_{B2}^2 \frac{I_{200}^{\text{full-order}}}{I_{220}^{\text{full-order}}}, \quad (2)$$

where I_{200}/I_{220} is an experimentally obtained intensity ratio between (200) and (220) diffraction lines, and $I_{200}^{\text{full-order}}/I_{220}^{\text{full-order}}$ is the (calculated) ideal diffraction intensity

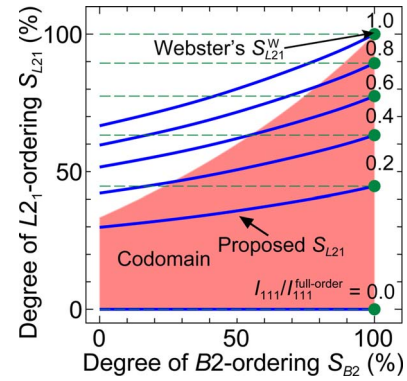


FIG. 2. (Color online) Degree of $L2_1$ ordering, S_{L2_1} , as a function of the degree of $B2$ ordering, S_{B2} , with various diffraction intensity ratios $I_{111}/I_{111}^{\text{full-order}}$. The solid curves show S_{L2_1} , and the solid circles $S_{L2_1}^W$ in the Webster framework. The filled region represents the codomain of S_{L2_1} given by $0 \leq S_{L2_1} \leq (1+S_{B2})/(3-S_{B2})$.

ratio for the perfect $B2$ structure (that is whole the X sites are occupied only by Co atoms). The expression of S_{B2} in our model corresponds to that in the Webster model ($S_{B2}=S_{B2}^W$). The degree of $L2_1$ ordering, S_{L2_1} , can be also defined by the following relation:

$$S_{L2_1} = \frac{n_{\text{Fe on } Y} - n_{\text{Fe on } Y}^{\text{random}}}{n_{\text{Fe on } Y}^{\text{full-order}} - n_{\text{Fe on } Y}^{\text{random}}} = \frac{2y - x}{2 - x}, \quad (3)$$

where $n_{\text{Fe on } Y}^{\text{random}} (=x/2)$ is the number of Fe atoms on the Y sites for the most random distribution of Fe atoms in the YZ sublattice, and $n_{\text{Fe on } Y}^{\text{full-order}}$ is that for the fully ordered YZ sublattice. The codomain of S_{L2_1} depends on S_{B2} and it is limited to a range of $0 \leq S_{L2_1} \leq \frac{1+S_{B2}}{3-S_{B2}}$. Note that S_{L2_1} can take a finite value even under $S_{B2}=0$ since $L2_1$ -ordering portion without Y - Z disordering can remain when the X sublattice are fully disordered (a half amount of whole the Fe and Si atoms is required for the fully disordered X sublattice). S_{L2_1} can be obtained from the following relation,

$$\frac{I_{111}}{I_{220}} = (2y - x)^2 \frac{I_{111}^{\text{full-order}}}{I_{220}^{\text{full-order}}} = \left[S_{L2_1} \left(\frac{3 - S_{B2}}{2} \right) \right]^2 \frac{I_{111}^{\text{full-order}}}{I_{220}^{\text{full-order}}}. \quad (4)$$

This relation can be easily deduced by the ordinary procedure¹¹ from crystal structure factors ($F_{111}=4|f_Y-f_Z|$ and $F_{220}=4|2f_X+f_Y+f_Z|$) and average atomic scattering factors at each site [$f_X=2xf_{\text{Co}}+(1-x)f_{\text{Fe}}+(1-x)f_{\text{Si}}$, $f_Y=(1-x)f_{\text{Co}}+yf_{\text{Fe}}+(x-y)f_{\text{Si}}$, and $f_Z=(1-x)f_{\text{Co}}+(x-y)f_{\text{Fe}}+yf_{\text{Si}}$]. It should be noted that S_{L2_1} cannot be determined only by the odd superlattice line, and that S_{L2_1} also depends on the degree of $B2$ ordering. In the Webster framework, $S_{L2_1}^W$ is given by $S_{L2_1}^W=1-2\alpha^W$ using the general definition shown in the second part of Eq. (3) and it is given by the relation of $I_{111}/I_{220}=S_{L2_1}^W{}^2 I_{111}^{\text{full-order}}/I_{220}^{\text{full-order}}$. When $S_{B2}=100\%$ ($x=1$), our S_{L2_1} formula ($=2y-1$) is identical with Webster's $S_{L2_1}^W (=1-2\alpha^W)$ (since $x=1$, Webster's disordering parameter is expressed by $\alpha^W=1-y$). Moreover, S_{L2_1} can evaluate the degree of $L2_1$ ordering under a particular S_{B2} value of $S_{B2} < 100\%$.

Figure 2 shows S_{L2_1} as a function of S_{B2} with various diffraction intensity ratios $I_{111}/I_{111}^{\text{full-order}}$. The solid curves

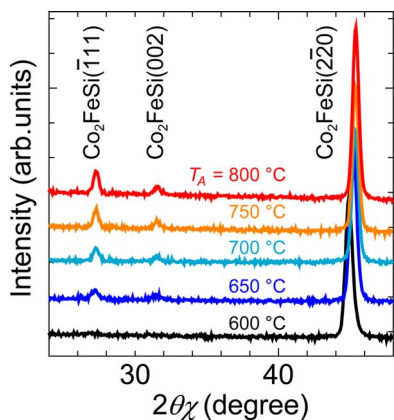


FIG. 3. (Color online) XRD patterns measured with in-plane configuration for the Co_2FeSi films formed at T_A ranging from 600 to 800 °C

show S_{L2_1} in our model, and the solid circles show $S_{L2_1}^W$ in the Webster framework that can be only plotted on $S_{B2}=100\%$. S_{L2_1} and $S_{L2_1}^W$ increase with increasing $I_{111}/I_{111}^{\text{full-order}}$. Although S_{L2_1} are identical with $S_{L2_1}^W$ when $S_{B2}=100\%$, S_{L2_1} decreases with decreasing S_{B2} . It should be emphasized that S_{L2_1} can be evaluated for overall S_{B2} , whereas $S_{L2_1}^W$ is only defined at $S_{B2}=100\%$ ($x=1$).

The developed model was applied to RTA-formed Co_2FeSi thin films.⁸ Recently, we reported that full-Heusler Co_2FeSi alloy thin films were successfully formed by RTA-induced silicidation reaction utilizing SOI substrates. Detailed experimental procedure was described in Ref. 8. After Co and Fe films were deposited on a SOI substrate in an ultrahigh vacuum, the silicidation was performed by RTA in N_2 atmosphere. RTA temperature T_A was varied in a range between 600–800 °C. The thicknesses of Co and Fe layers were determined so that the stoichiometric composition was achieved. The depth profiles of constituent elements were observed by secondary ion mass spectroscopy (SIMS) with MCs^+ technique,¹³ whose signals were calibrated by Rutherford backscattering (RBS) and particle induced x-ray emission (PIXE) measurements. The composition of the sample formed at $T_A=800$ °C was homogeneous and stoichiometric. The concentrations of Co, Fe, and Si in the Co_2FeSi film were 49%, 26%, and 25%, respectively.

The crystallographic features of the samples were characterized by XRD. XRD patterns for the samples formed above $T_A=600$ °C showed $\text{Co}_2\text{FeSi}(220)$ and $\text{Co}_2\text{FeSi}(440)$ diffraction. Pole figure analysis for the (220) fundamental diffraction revealed that the RTA-formed Co_2FeSi thin films were highly (110) oriented columnar polycrystalline. This result was consistent with our transmission electron microscopy (TEM) observation.

In-plane XRD measurements were performed to evaluate intensity ratios between superlattice and fundamental diffraction lines that characterize the degree of $B2$ and $L2_1$ orderings. Since the RTA-formed Co_2FeSi films were (110)-oriented columnar polycrystalline, the three important diffraction lines of (-111) , (002) , and $(2-20)$ can be detected simultaneously in in-plane measurements. As a result,

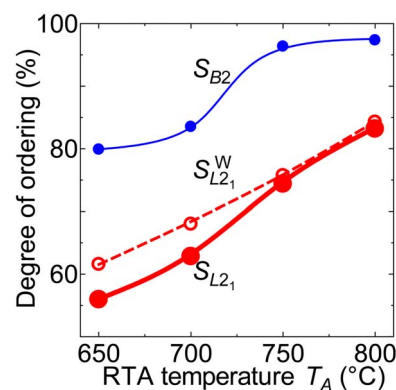


FIG. 4. (Color online) Degree of $B2$ and $L2_1$ orderings, S_{B2} , and S_{L2_1} , as a function of RTA temperature T_A . The thin solid curve represents S_{B2} , the thick solid curve S_{L2_1} . The degree of $L2_1$ ordering in the Webster framework, $S_{L2_1}^W$, is also shown by the dashed curve in the figure.

accurate intensity relations were obtained without complicated corrections. Figure 3 shows XRD patterns measured with in-plane configuration for the samples formed at T_A ranging from 600 to 800 °C. Above $T_A=650$ °C, the three (-111) , (002) , and $(2-20)$ diffraction peaks were clearly observed, indicating the formation of the $L2_1$ ordered structure. The degree of atomic orderings in the films was estimated using these intensity ratios. Figure 4 shows S_{B2} , S_{L2_1} , and $S_{L2_1}^W$, as a function of T_A . In order to deduce these indices, the intensity ratios $I_{002}^{\text{full-order}}/I_{2-20}^{\text{full-order}}$ and $I_{-111}^{\text{full-order}}/I_{2-20}^{\text{full-order}}$ shown in Eqs. (2) and (4), respectively, were calculated using International diffraction tables for crystallography volume C and D with the correction of multiplicity. The sample formed at $T_A=800$ °C showed a high degree of atomic ordering of $S_{L2_1}=83\%$ under $S_{B2}=97\%$. It is clearly shown that $S_{L2_1}^W$ was overestimated in comparison with S_{L2_1} , and that the deviation from S_{L2_1} increased with decreasing S_{B2} as described in Fig. 4.

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